

Application Data Sheet

Application Information

Application number::	Unassigned
Filing Date::	02/13/2004
Application Type::	Regular
Subject Matter::	Utility
Suggested classification::	
Suggested Group Art Unit::	
CD-ROM or CD-R?::	None
Computer Readable Form (CRF)?::	No
Title::	APPARATUS AND METHOD FOR THIN-LAYER METROLOGY
Attorney Docket Number::	016790-0489
Request for Early Publication?::	No
Request for Non-Publication?::	No
Suggested Drawing Figure::	
Total Drawing Sheets::	5
Small Entity?::	No
Petition included?::	No
Secrecy Order in Parent Appl.?::	No

Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Federal Republic of Germany
Status::	Full Capacity
Given Name::	Matthias
Family Name::	SLODOWSKI
City of Residence::	Jena
Country of Residence::	Germany

Street of mailing address:: Ricarda-Huch-Weg 24
07743 Jena
Country of mailing address:: Germany

Correspondence Information

Correspondence Customer Number:: 22428
E-Mail address:: PTOMailWashington@Foley.com

Representative Information

Representative Customer Number::	22428	
---	-------	--

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Federal Republic of Germany	103 08 258.1	02/25/2003	Yes

Assignee Information

Assignee name:: LEICA MICROSYSTEMS JENA GmbH